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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SAKURAI et al.

Group Art Unit: 1794

Application No.: 10/533,546

Examiner: M. JACKSON

Filed: May 2, 2005

Docket No.: 123653

For: A METHOD FOR FORMING A THIN FILM OF SILVER MIRROR AND A METHOD
FOR FORMING A COATED FILM CONTAINING SAID THIN FILM OF SILVER
MIRROR

CLARIFICATION OF INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

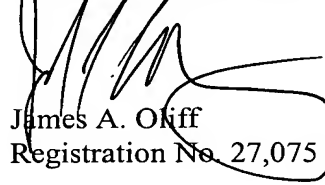
Sir:

In the Information Disclosure Statement filed October 22, 2008, Applicants provided English language versions of the Japanese Office Actions dated July 5, 2005 and November 22, 2005. However, a typographical error was found in the filed Information Disclosure Statement description.

On page 2 of the Information Disclosure Statement, JP A 2000-234715 was indicated as being cited by both of the above English language versions of the Japanese Office Actions. However, the correct citation is JP A 2000-234175, as reflected on page 5, line 26 and page 14, line 1, respectively, of the July 5, 2005, and November 22, 2005, Office Actions.

Further, Applicants confirm that the correct reference, JP A 2000-234175, was previously properly cited to the Patent Office by Applicants in the Information Disclosure Statement submitted May 2, 2005.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Joel S. Armstrong
Registration No. 36,430

JAO:JSA/sxl

Date: November 13, 2008

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

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